

10/584771

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OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet

Applicant Information

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Isao
Family Name::	YOKOKAWA
State or Province of Residence::	Gunma
Country of Residence::	Japan

Correspondence Information

Correspondence Customer Number::	25944
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Application Information

Application Type::	National Phase
Subject Matter::	Utility
CD-ROM or CD-R::	None
Title::	METHOD FOR MEASURING AN AMOUNT OF STRAIN OF A BONDED STRAINED WAFER
Attorney Docket Number::	128503
Suggested Drawing Figure::	3
Total Drawing Sheets::	8
Small Entity::	No

Representative Information

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Domestic Priority Information					
Application::	Continuity Type::	Parent Application::	Parent Filing Date::		
This Application is a	National Phase of	PCT/JP2005/000165	January 11, 2005		
Foreign Priority Information					
Country::	Application Number::	Filing Date::	Priority Claimed::		
Japan	2004-8744	January 16, 2004	Yes		
Assignee Information					
Assignee Name::	SHIN-ETSU HANDOTAI CO., LTD.				
Street of mailing address::	4-2, Marunouchi 1-chome, chiyoda-ku				
City of mailing address::	Tokyo				
Country of mailing address::	Japan				